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(Not for submission under 37 CFR 1.99)

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| Application Number | 10595434 |
| Filing Date | 2006-04-19 |
| First Named Inventor | Siegfried Karg |
| Art Unit | N/A |
| Examiner Name | N/A |
| Attorney Docket Number | CH920030009US1 |

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| | 1 | Yau S T et al: "Laser-Assisted Deposition of Nanometer Structures Using A Scanning Tunneling Microscope" Applied Physics Letters, American Institute of Physics, New York, US, vol. 57, no. 27, 31 December 1990, pages 2913-2915 XP000222958 ISSN: 0003-6951 the whole document | <input type="checkbox"/> |
| | 2 | Shtokman M I: "Possibility of Laser Nanomodification of Surfaces by Means of a Scanning Tunneling Microscope" Optoelectron Instrum Data Process; Optoelectronics, Instrumentation and Data Processing (English Translation of Avtometriya) 1989, no. 3 1989 pages 27-37, XP009043144 page 27, paragraph 1 pages 28-29 pages 33-36 | <input type="checkbox"/> |
| | 3 | Boneberg J, et al.: "Mechanism of Nanostructuring Upon Nanosecond Laser Irradiation of a STM Tip" Appl Phys A; Applied Physics A: Materials Science & Processing OCT 1998 Springer-Verlag GMBH & Company KG, Berlin, Germany, vol. 67, no. 4, October 1998 (1998-10), pages 381-384, XP002315242 page 381, right-hand column | <input type="checkbox"/> |

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| | Attorney Docket Number | | CH920030009US1 |

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See attached certification statement.
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A signature of the applicant or representative is required in accordance with CFR 1.33, 10.18. Please see CFR 1.4(d) for the form of the signature.

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| Signature | /Yuanmin Cai/ | Date (YYYY-MM-DD) | 2006-04-26 |
| Name/Print | Yuanmin Cai | Registration Number | 56513 |

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